

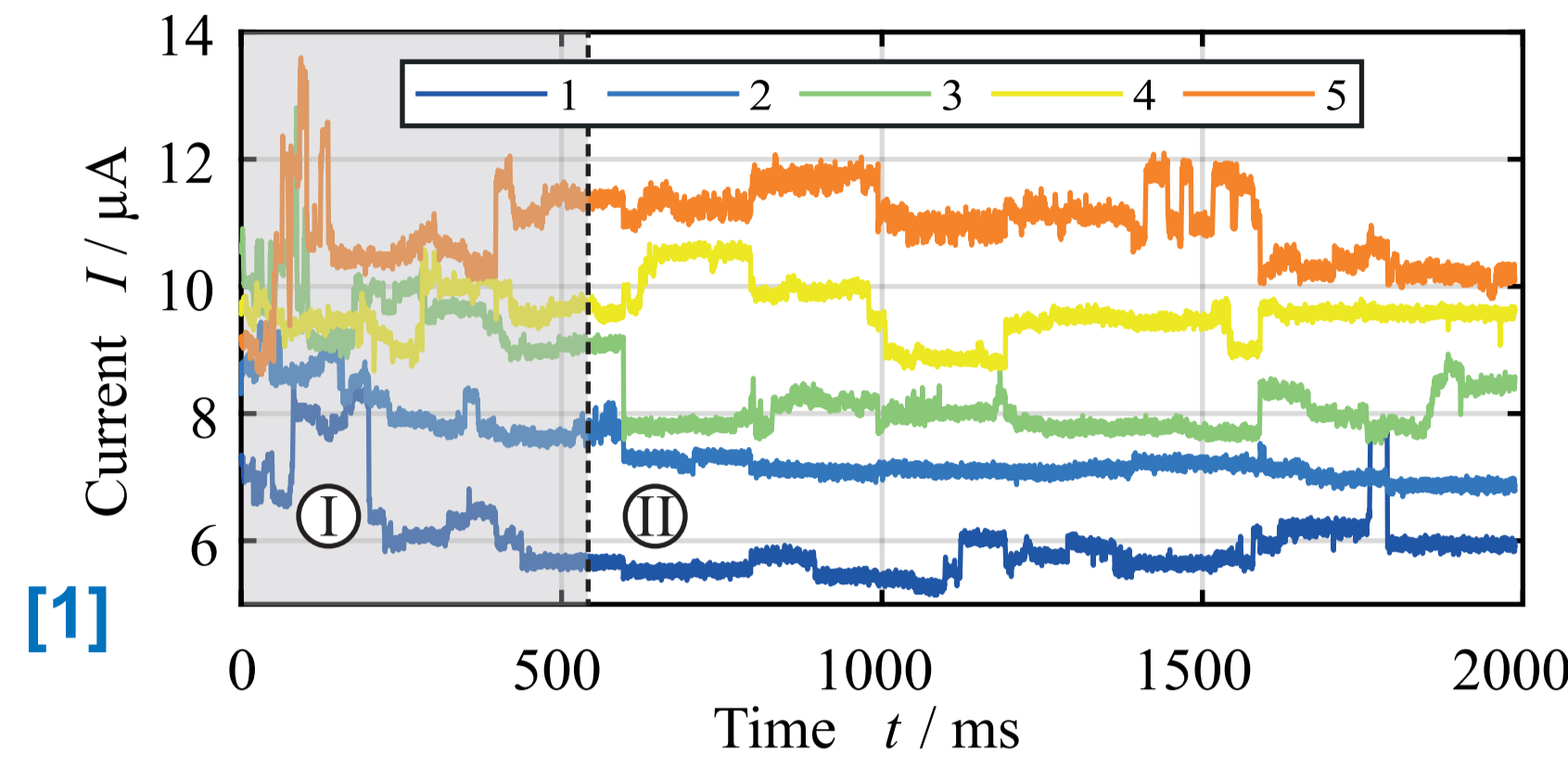
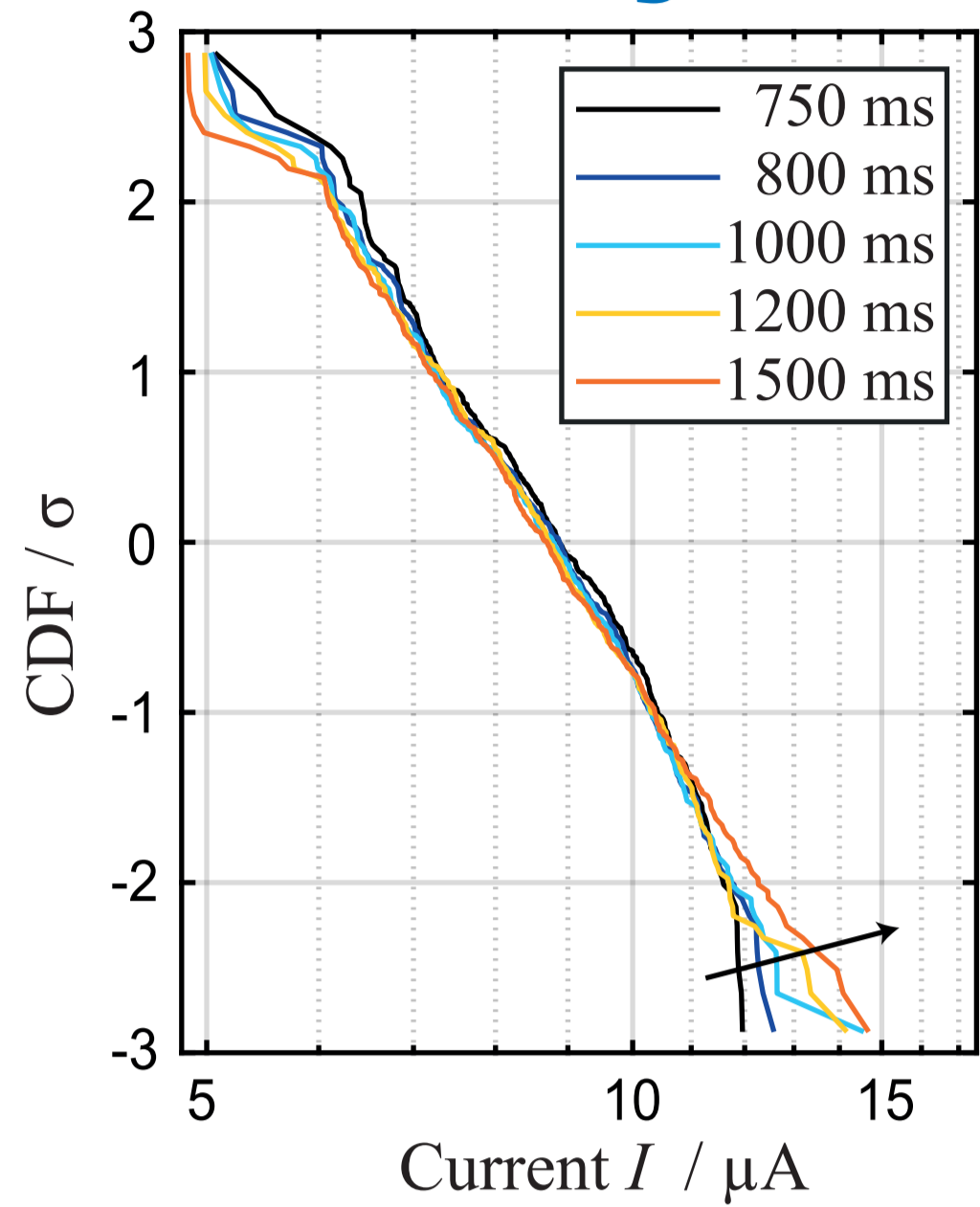
Consistent Modelling of Instability and Retention Phenomena in Filamentary Valence Change Memories

N. Kopperberg¹, S. Wiefels², S. Liberda¹, R. Waser^{1,2} and S. Menzel²

¹ Institut für Werkstoffe der Elektrotechnik II, RWTH Aachen, Aachen, 52074, Germany, ² Peter Grünberg Institut, Forschungszentrum Jülich GmbH, Jülich, 52425, Germany

Motivation

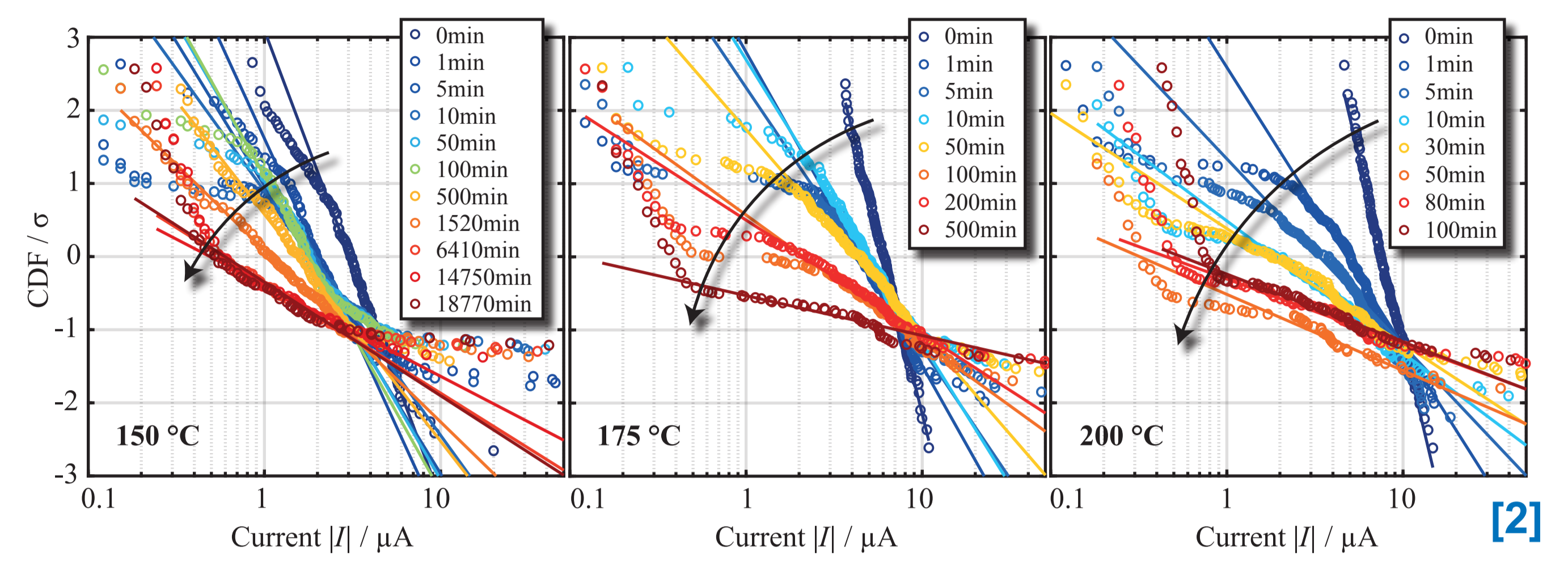
Instability



- Experimental read current of ZrO₂ based VCM ReRAM in the high resistive state (HRS)
- Overall current distribution stable over time, current of single devices changes and jumps between discrete levels

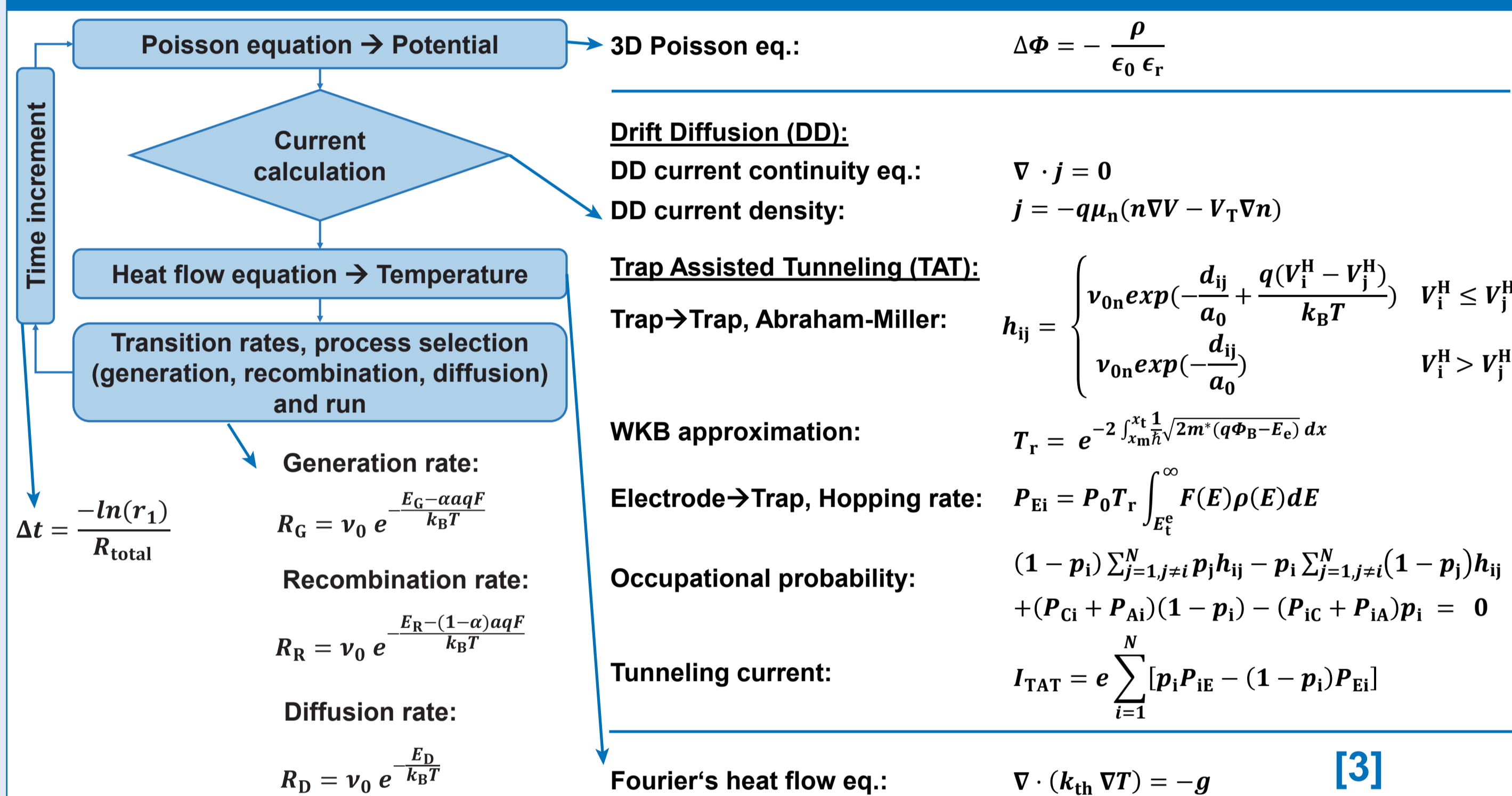
- Failure of shaping algorithms trying to widen read window
- Current distribution always reverts to intrinsic distribution

Retention

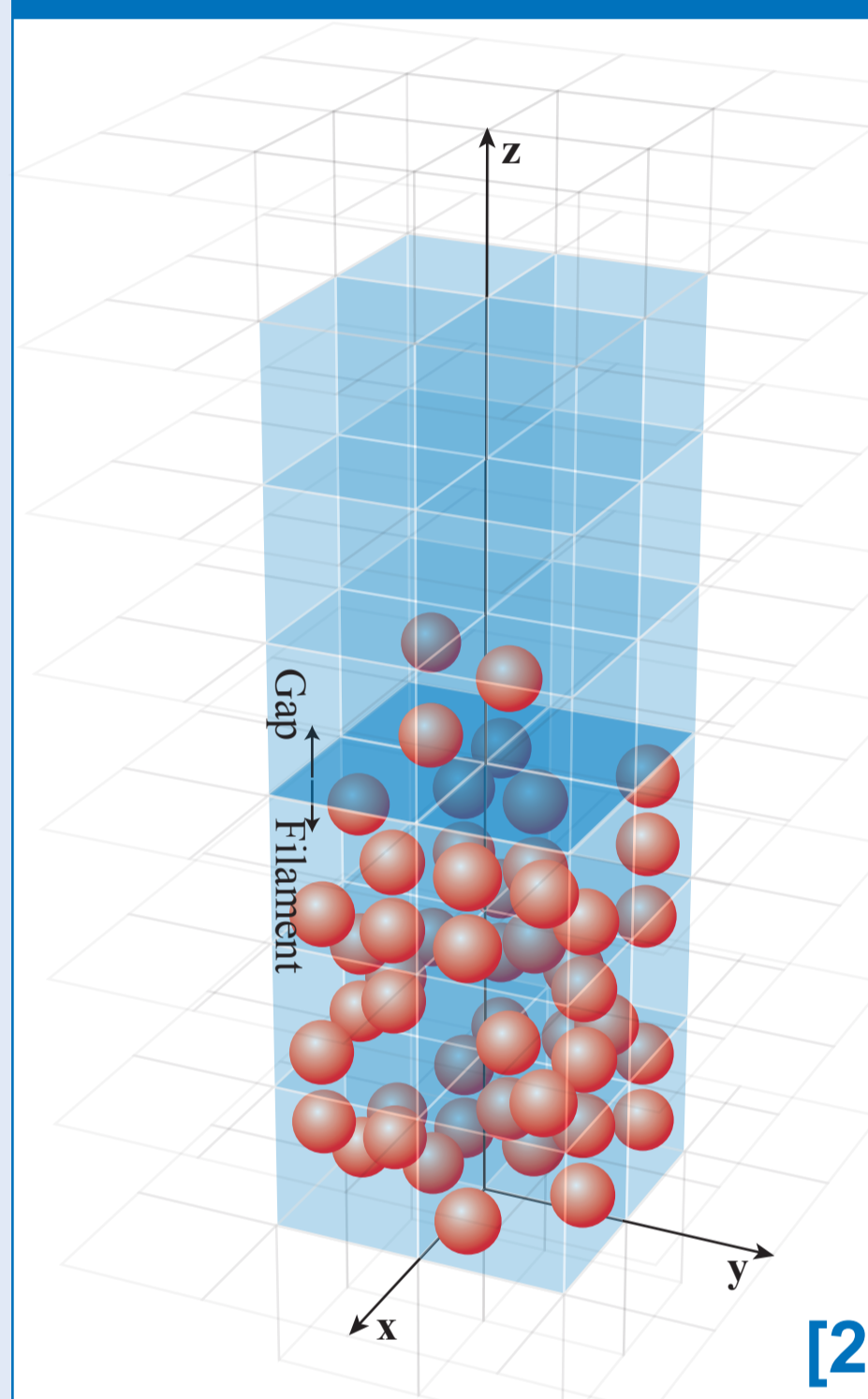


- Current distribution not stable at comparably large timescales
- Thermally accelerated retention experiments
- Tilt (broadening) and shift of current distribution observed during 'baking'
- Read window becomes smaller

KMC Model



Multi Domain Model

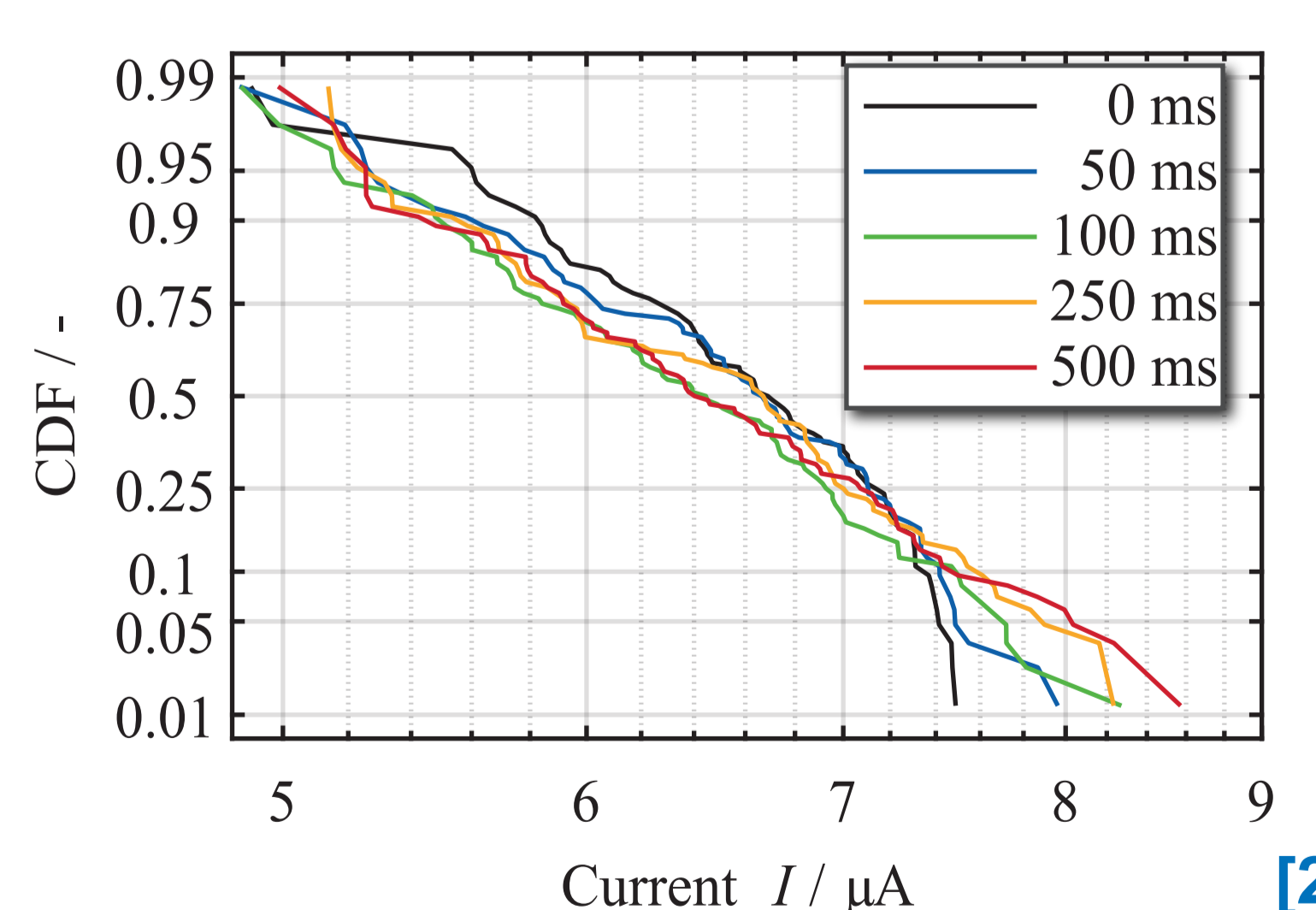
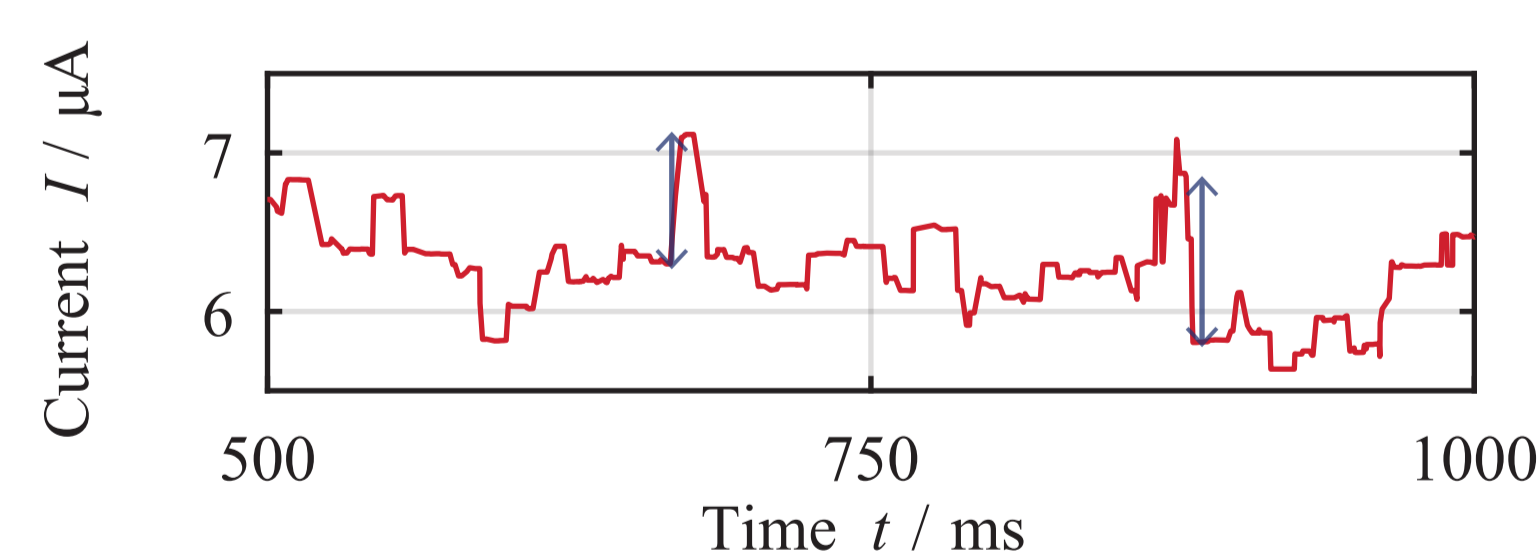
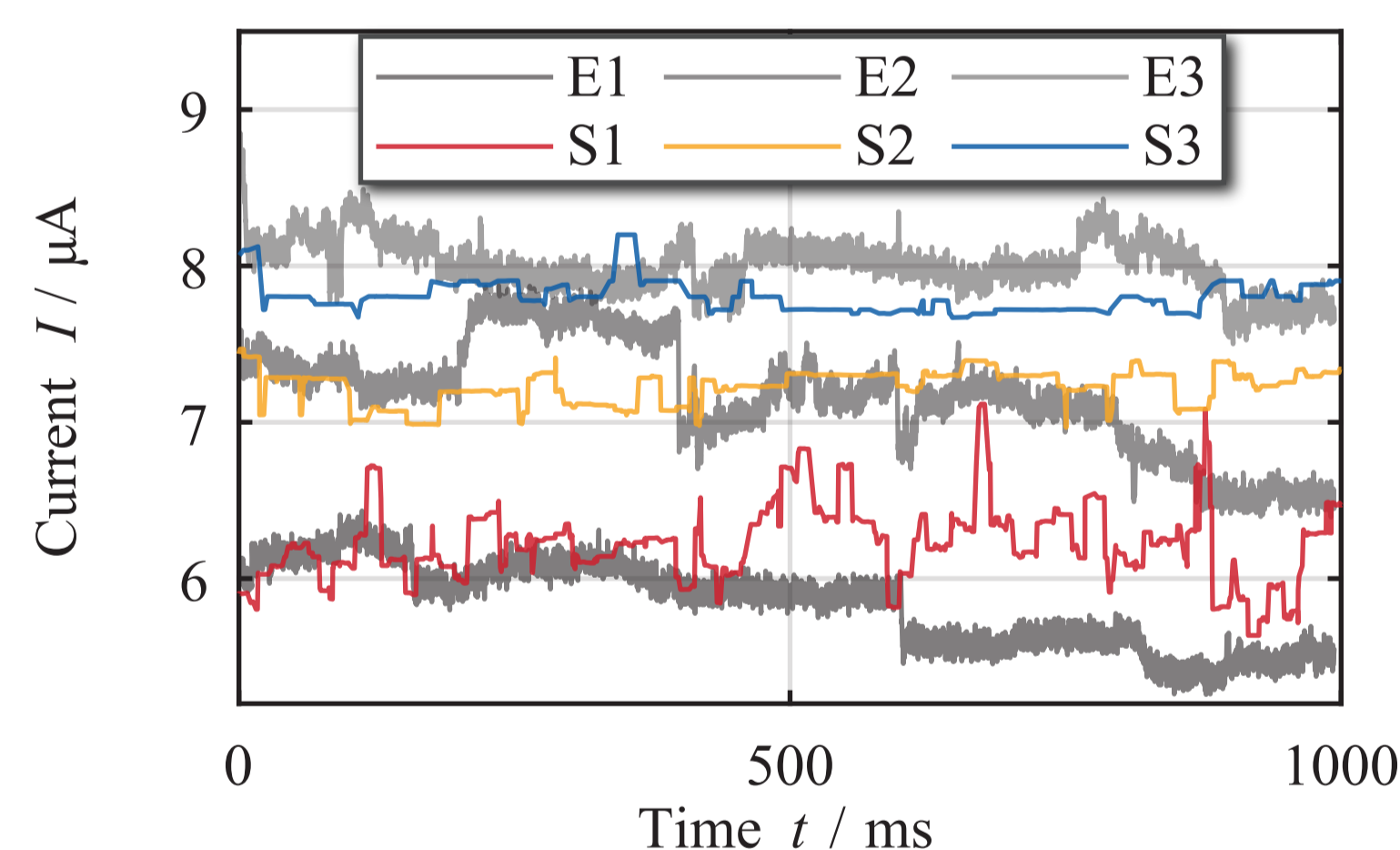


- Different diffusion regimes observed in molecular dynamics simulations for oxygen vacancies in HfO₂ [4]
- Introduction of diffusion-limiting domains
- Modelled by boxes with 'easy' diffusion inside, but hindered diffusion of oxygen vacancies from box to box
- Investigation of HRS which is most susceptible to instability and retention failures
- Modelled by comparably low number of defects in filament with large gap between filament and electrically active top electrode
- Goal: Explain short-term instability and long-term retention phenomena in the same model by the same physical processes (random distribution and diffusion of oxygen vacancies)

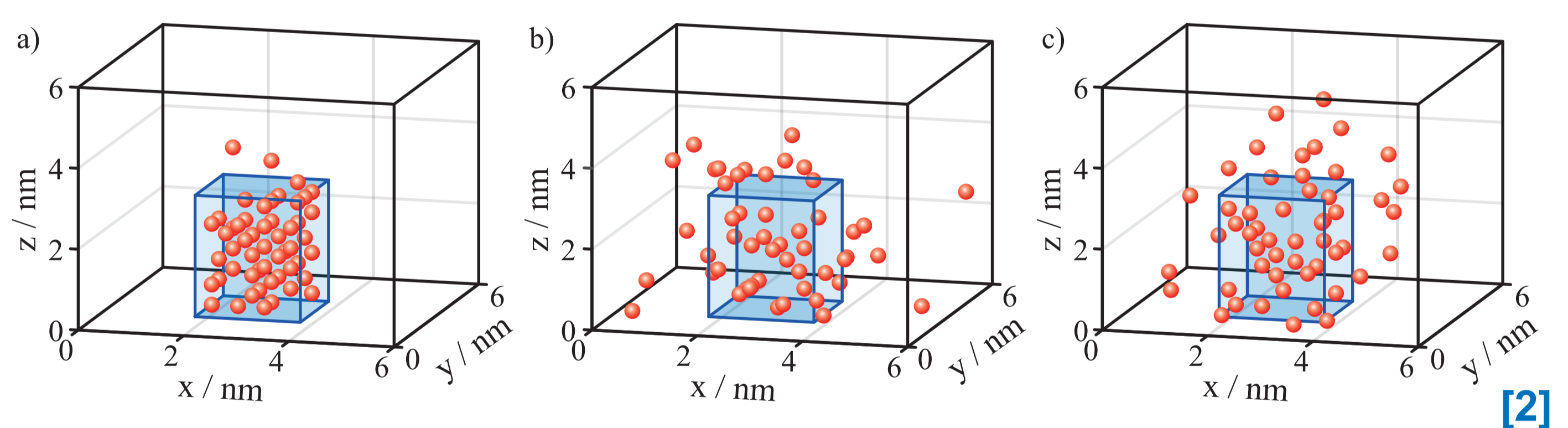
Results

Instability

- Read current investigation at room temperature
- Defects jump and rearrange inside boxes, but cannot overcome high barriers (no structural changes)
- Discrete random jumps of current of single cells due to oxygen vacancy diffusion
- Highest current jumps originate from oxygen vacancy jumps close to filament-gap interface
- Read current distribution stable over time
- Shaping failure can be modelled and explained by the random redistribution of oxygen vacancies
- Random diffusion of oxygen vacancies leads to intrinsic log-normal current distribution

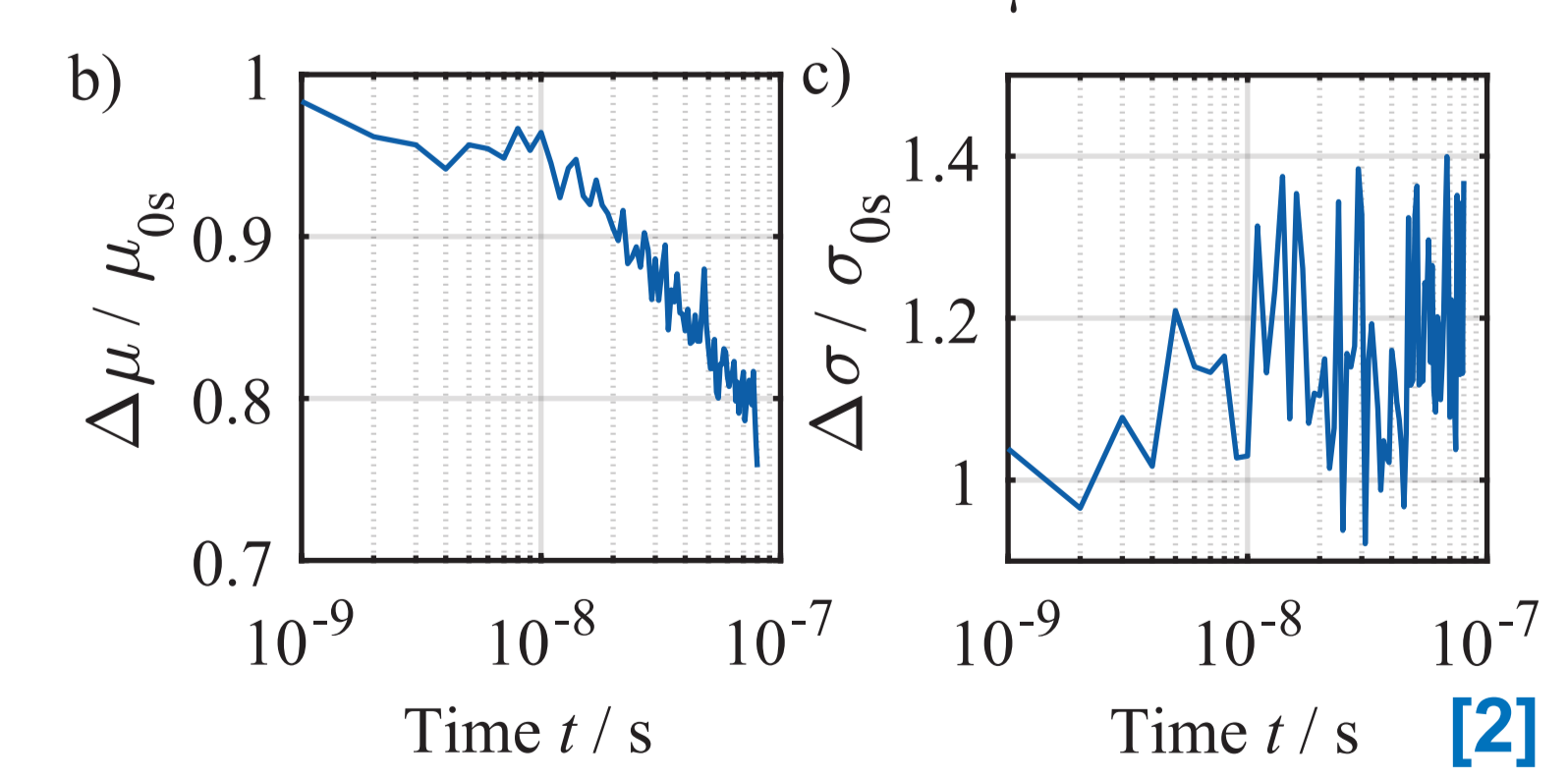
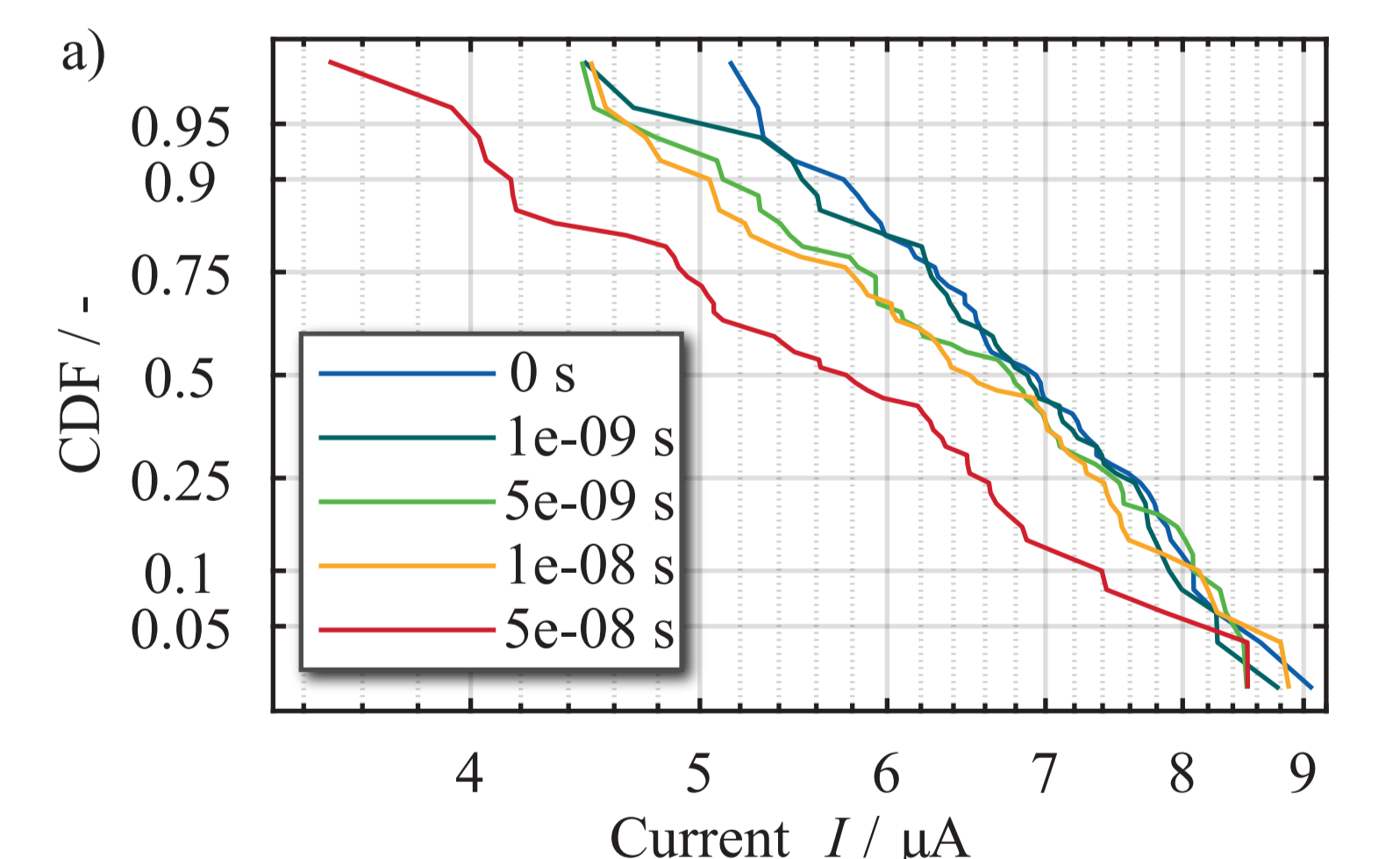


Retention



- Simulation of retention phenomena at highly elevated temperatures
- Oxygen vacancies can overcome barriers and also jump from box to box (structural changes)
- Radial diffusion (b) or vertical diffusion closing the gap (c) can be reached from initial state (a)
- Usually, superposition of both processes

- Tilt of distribution (always) and shift of distribution depending on which process dominates (radial diffusion or closing gap)
- Diffusion of oxygen vacancies sufficient to explain retention phenomena



Conclusion

- Different possible sources of retention effects in VCM ReRAMs have been investigated. Regions with different diffusion energy barriers have been introduced - here, both instability and retention effects can be explained by one consistent model.
- Due to the random fluctuations, the read current follows intrinsic statistics. A transition from log-normal to normal statistics is observed from HRS towards LRS. The origin of the intrinsic statistics will be further investigated. Connection to the conduction mechanism: localized vs delocalized electrons, area vs filamentary switching. Read noise in different oxides will be compared.

[1] S. Wiefels, C. Bengel, N. Kopperberg, K. Zhang, R. Waser and S. Menzel, "HRS Instability in Oxide-Based Bipolar Resistive Switching Cells," in *IEEE Transactions on Electron Devices*, vol. 67, no. 10, pp. 4208-4215, Oct. 2020, doi: 10.1109/TED.2020.3018096.

[2] N. Kopperberg, S. Wiefels, S. Liberda, R. Waser, S. Menzel; A Consistent Model for HRS Short-Term Instability and Long-Term Retention Mechanisms in Filamentary VCM ReRAM; *ACS Applied Materials & Interfaces* 2021 13(48), 58066-58075, doi: 10.1021/acsaami.1c14667.

[3] E. Abbaspour, S. Menzel, A. Hardtdegen, S. Hoffmann-Eifert, C. Jungemann. "KMC Simulation of the Electroforming, Set and Reset Processes in Redox-based Resistive Switching Devices". In: *IEEE Trans. Nanotechnol.* 17.6 (2018), pp.1181-1188

[4] M. Schie, M. P. Müller, M. Salinga, R. Waser, R. A. De Souza. "Ion Migration in Crystalline and Amorphous HfO_x". In: *The Journal of Chemical Physics* 146, 094508 (2017).